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TC 1700

Docket No.: 49677-091

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shinichi YAMAGATA, et al.

Serial No.: 09/925,427

Group Art Unit: 1742

Filed: August 10, 2001

Examiner: Daniel J. Jenkins

7/c
P-6
03/26/03

For: SUBSTRATE MATERIAL FOR MOUNTING A SEMICONDUCTOR DEVICE,
SUBSTRATE FOR MOUNTING A SEMICONDUCTOR DEVICE,
SEMICONDUCTOR DEVICE, AND METHOD OF PRODUCING THE SAME

AMENDMENT

Commissioner for Patents
Washington, DC 20231

Sir:

The following amendment and remarks are submitted in response to the Office
Action dated December 23, 2002. Please amend the above-identified application as
follows. The claims are presented in the revised amendment format described in the Pre-
OG Notice dated January 31, 2003, regarding waiver of the current provisions of 37 CFR
§§ 1.121(a) - 1.121(d). Favorable reconsideration is respectfully solicited.